



Serial No. 09/843,023  
Attorney Docket No. 40013-0002

2823

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#10/Electron  
198/a  
vs

In re Patent Application:  
Becky Losee

Serial No.: 09/843,023

Filed: April 26, 2001

For: METHODS FOR ETCHING SILICON  
TRENCHES

Confirmation No. 7229

Group Art Unit: 2823

Examiner: J. Maldonado

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Commissioner for Patents  
Washington, D.C. 20231

Box Non-Final Response

Sir:

**RESPONSE TO RESTRICTION REQUIREMENT**

In response to the Office Action dated August 21, 2002 Applicant requests reconsideration of the restriction requirement and examination of all claims in light of the following remarks.

Remarks

The Office required restriction to one of the following groups of inventions under 35 U.S.C. § 121:

Group I: claims 1-24, drawn to a method of manufacturing a semiconductor device, classified in class 438, subclass 709; and

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D. C. 20231, on this 20<sup>th</sup> day of September 2002.

Signed: Emily J. Forey  
Dated: 9/20/02

9/20/2002